

Attorney Docket No. 0756-7197

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 10/664,916

Filed: September 22, 2003

For: BEAM HOMOGENIZER AND LASER

IRRADIATION APPARATUS AND

METHOD OF MANUFACTURING

SEMICONDUCTOR DEVICE

) Group Art Unit: 1722

) Examiner: R. Kunemund

) CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on August 13, 2007.

) Adeline M. Stamps

INFORMATION DISCLOSURE STATEMENT

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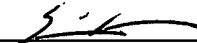
Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing information known to Applicant and requests that this information be made of record in the above identified application. Copies are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Copies of U.S. patents and U.S. publications are not enclosed in accordance with the Notice published in the Official Gazette on August 5, 2003 entitled *Information Disclosure Statements May Be Filed Without Copies of U.S. Patents and Published Applications in Patent Applications filed after June 30, 2003*, which waives the requirement under 37 CFR 1.98(a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. publication.

This Information Disclosure Statement is being submitted with an RCE.
Therefore, no fee is required.

Respectfully submitted,



Eric J. Robinson
Reg. No. 38,285

Robinson Intellectual Property Law Office, P.C.
PMB 955
21010 Southbank Street
Potomac Falls, Virginia 20165
(571) 434-6789

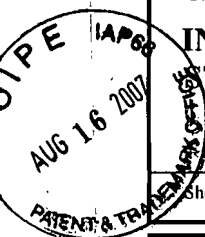
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	
				10/664,916	
				Filing Date	
				September 22, 2003	
				First Named Inventor	
		Koichiro TANAKA			
Group Art Unit		1722			
Examiner Name		R. Kunemund			
Attorney Docket Number		0756-7197			
Sheet	1	of	1		

U.S. PATENT DOCUMENTS						
Examiner Initials [*]	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
		2002/0196419		Mizouchi	12/26/2002	
		2003/0024905		Tanaka	02/06/2003	
		4,733,944		Fahlen et al.	03/29/1988	
		6,236,449		Tanitsu	05/22/2001	
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FOREIGN PATENT DOCUMENTS							
Examiner Initials [*]	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Office ³	Number ⁴	Kind Code ⁵ (if known)			
		CN	1448753			10/15/2003	Full
		EP	0 747 772			12/11/1996	Abst.
		EP	0 805 368			11/05/1997	Abst.
		JP	2003-287703			10/10/2003	Full

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials [*]	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		KAHLERT et al., Poly-Silicon Thin Film Transistor Technology and Applications in Displays and Other Novel Technology Areas, <i>High Resolution Optics For Thin Si-Film Crystallization Using Excimer Lasers: Present Status and Future Development</i> , Vol. 5004 (2003), pp. 20-27.	

Examiner Signature	Date Considered
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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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